



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of : **Confirmation No. 5731**  
Akihisa HONGO et al. : Attorney Docket No. 2001\_0133A  
Serial No. 09/762,582 : Group Art Unit 1753  
Filed April 12, 2001 : Examiner Arun Phasge  
SUBSTRATE PLATING  
METHOD AND APPARATUS : **Mail Stop: Amendment**

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of June 10, 2005, the period for response to which having been extended by two months to November 10, 2005, please amend the above-identified U.S. Patent application as follows: